Electronic Supplementary Information

Hybrid Microchannel-Solid State Micropore device for fast and optical cell detection

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1. Dependence of control variables on the pore fabrication process and the silicon surface

Silicon wafers	Ra (nm)
KOH-50-HCl-40-0.5	2
KOH-50-HCl-40-0.1	2
КОН-50-НСООН-40-0.5	6
КОН-50-НСООН-40-0.1	13
KOH-50-HCl-60-1	3
KOH-50-HCl-60-0.5	5
КОН-50-НСООН-60-0.5	7
KOH-50-HCl-80-1	2
КОН-50-НСООН-80-1	5
КОН-50-НСООН-80-0.1	7

 Table S1. Characterization of Surface Roughness of micropores

The codes of the micropores correspond with the concentration of the KOH, followed by the acid, temperature and voltage applied during the electrochemical etching.

2. Dependence of control variables on the electrical characterization



Figure S1. Opening pore time comparison

3. Application

Cell quantification

Macro: Cells in focus under Microscopy bright field

4. Simulation



Fig S2. Pressure drop distribution in the micropore and PDMS microchannel at varying flow rates and viscosities.



Fig S3. Shear stress distribution in the micropore and PDMS microchannel at varying flow rates and viscosities.



Figure S4. Velocity profiles distribution in the micropore and PDMS microchannel at varying flow rates and viscosity of 0.89 cP.

Video 1: Functionality of the microfluidic device for visual detection and counting cells.